# EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|---|---|---|---|---|---|---|
| L6 | 2 | "5807165".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 15:01 |
| L7 | 2 | "6780772".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 15:04 |
| L9 | 84 | barrier adj layer with electropolish$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 15:05 |
| L10 | 2 | "10602488".rlan. or ("10".src. and "602488".ap.) | US-PGPUB; USPAT; USOCR; DERWENT | OR | ON | 2006/09/21 15:18 |
| L11 | 135 | ("5807165").URPN. | USPAT | OR | ON | 2006/09/21 15:56 |
| L12 | 765 | 205/640-683.ccls. and (semiconductor wafer electronic microelectronic microfeature) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 15:57 |
| L13 | 41 | L12 and cup | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 16:02 |
| L14 | 179 | L12 and seal$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 16:09 |
| L15 | 2 | "4466864".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/21 16:10 |